

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of :  
Shunji Hayashi : Attn: Applications Branch  
Continuation of Serial No.: 10/206,067 : Attorney Docket No. SKI.008C2  
Filed: November 14, 2003 :  
For: METHOD AND SYSTEM FOR MANAGING SEMICONDUCTOR  
MANUFACTURING EQUIPMENT

**PRELIMINARY AMENDMENT**

U.S. Patents and Trademark Office  
2011 South Clark Place  
Customer Window, **Mail Stop Patent Application**  
Crystal Plaza Two, Lobby, Room 1B03  
Arlington, VA 22202

Date: November 14, 2003

Sir:

Preliminary to the examination of the above-identified application, please enter the following amendments and remarks.

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 3 of this paper.

**Remarks/Arguments** begin on page 8 of this paper.